



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG755507011
Report verification at igi.org

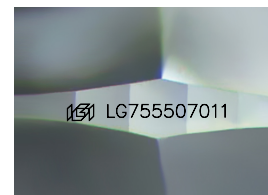
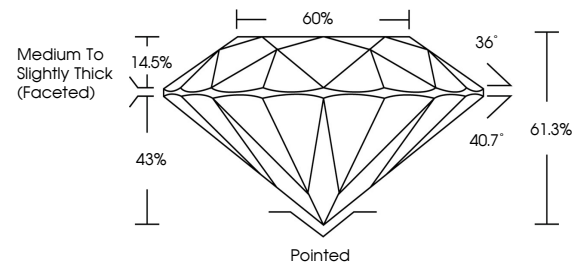
January 30, 2026	
IGI Report Number	LG755507011
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	8.07 - 8.11 X 4.96 MM
GRADING RESULTS	
Carat Weight	2.02 CARATS
Color Grade	E
Clarity Grade	VS 1
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG755507011

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

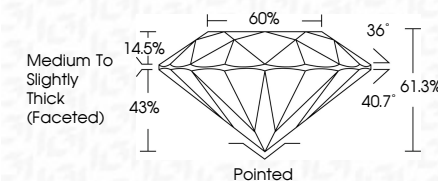
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

January 30, 2026
GI Report No LG755507011
ROUND BRILLIANT

0.07 - 0.11 X 4.95 MM	Carat Weight	2.02 CARATS
	Color Grade	E
	Clarity Grade	VS 1
	Cut Grade	IDP&L
	Depth	61.9%
	Table	60%
	Girdle	Medium To Slightly Thick (Faceted)
	Culet	Pointed
	Polish	EXCELLENT
	Symmetry	EXCELLENT
	Fluorescence	NONE
	Report#	456112755202011

Comments:
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created by Chemical Vapor Deposition
(CVD) growth process.